

10/047627



01/14/02

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10047627	FILING DATE 01/14/2002	CLASS 073	SUBCLASS 71	GAU 2835	EXAMINER E
----------------------	---------------------------	--------------	----------------	-------------	---------------

\*\*APPLICANTS: Yamamoto Satoshi; Nakao Osamu; Nishimura Hitoshi; Sato Masahiro;

\*\*CONTINUING DATA VERIFIED:

BEST AVAILABLE COPY

\*\* FOREIGN APPLICATIONS VERIFIED:

JAPAN P2001-007750 01/16/2001

JAPAN P2001-007750 01/16/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 113197-020
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		
Verified and Acknowledged Examiners's initials		
TITLE : Pressure sensor and manufacturing method thereof		

U.S. DEPT. OF COMM /PAT. & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner PREPARED FOR ISSUE Application Examiner	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH: ☐ DISK (CRF) ☐ CD-ROM  
(Attached in pocket on right inside flap)